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Bib Data Sheet

CONFIRMATION NO. 6151

SERIAL NUMBER 10/701,035	FILING DATE 11/03/2003  RULE	CLASS 430	GROUP ART UNIT 1756	ATTORNEY DOCKET NO. 021653-002800US
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APPLICANTS

Chi-Yuan Hung, Shanghai, CHINA;

\*\* CONTINUING DATA \*\*\*\*\*

NONE *for*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

CHINA 03151440.5 09/29/2003 *for*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 02/11/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY CHINA	SHEETS DRAWING 5	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged Examiner's Signature <i>for</i> Initials			

ADDRESS

20350  
 TOWNSEND AND TOWNSEND AND CREW, LLP  
 TWO EMBARCADERO CENTER  
 EIGHTH FLOOR  
 SAN FRANCISCO , CA  
 94111-3834

TITLE

Method and structure for fabricating patterns on phase shift mask for the manufacture of semiconductor wafers

FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____
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